

BAR CODE LABEL



U.S. PATENT APPLICATION

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT
07/863,791	04/06/92	430	1507

APPLICANT
JANG F. CHEN, SAN JOSE, CA; JAMES A. MATTHEWS, MILPITAS, CA.

CONTINUING DATA***
VERIFIED

FOREIGN/PCT APPLICATIONS***
VERIFIED

FOREIGN FILING LICENSE GRANTED 05/06/92

STATE OR COUNTRY	Sheets Drawing	TOTAL CLAIMS	INDEPENDENT CLAIMS	FILING FEE RECEIVED	ATTORNEY DOCKET NO.
CA	7	23	3	\$1,010.00	57017.P025

ADDRESS	BLAKELY, SOKOLOFF, TAYLOR & ZAFMAN 12400 WILSHIRE BLVD., 7TH FL. LOS ANGELES, CA 90025
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TITLE	METHOD FOR IMPROVED LITHOGRAPHIC PATTERNING IN A SEMICONDUCTOR FABRICATION PROCESS
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This is to certify that annexed hereto is a true copy from the records of the United States Patent and Trademark Office of the application as filed which is identified above.

By authority of the
COMMISSIONER OF PATENTS AND TRADEMARKS

Date

Certifying Officer

BAR CODE LABEL



U.S. PATENT APPLICATION

SERIAL NUMBER	FILING DATE	CLASS	GROUP ART UNIT
07/863,791	04/06/92	430	1503

APPLICANT

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JANG F. CHEN, SAN JOSE, CA; JAMES A. MATTHEWS, MILPITAS, CA.
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 12400 WILSHIRE BLVD., 7TH FL.
 LOS ANGELES, CA 90025

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